Session Title: 15. TFT Manufacturing

Session Date: August 23 (Wed.), 2023

Session Time: 10:50-12:15

Session Room: Room G (314~315)

Session Chair(s): Prof. Jeong Hyun Kwon (Sunmoon Univ., Korea)

[G15-1] [Invited] 10:50-11:15

Processes and Circuit Designs for Co-Fabricated Enhancement and Depletion IGZO Thin Film Transistors

Norbert Fruehauf, Yannick Schellander, Hanghang Li, and Florian Kleber (Univ. of Stuttgart, Germany)

[G15-2] 11:15-11:30

Enhanced Electrical Characteristics and Stability of IGZO Using LWD Passivation Layer Deposited by EHD Jet Printing

Young Wook Kim, Min Seong Kim, Jong Hyuk Ahn, Sujin Lee, and Hyun Jae Kim (Yonsei Univ., Korea)

[G15-3] 11:30-11:45

High Performance  $In_2O_3$  Thin Film Transistor on Polyimide Substate via Atmospheric Pressure Spatial ALD

Kwang Su Yoo, Chi-Hoon Lee, Dong-Gyu Kim, and Jin-Seong Park (Hanyang Univ., Korea)

[G15-4] 11:45-12:00

Indium-Gallium-Zinc Oxide Thin-Film Transistor with High Subthreshold Slope by Gradual UV Treatment for Driving Transistor

Sujin Lee, Jusung Chung, Hyung Tae Kim, Jae Seong Han, and Hyun Jae Kim (Yonsei Univ., Korea)

[G15-5] 12:00-12:15

Effect of UV/Ozone Treatment on Threshold Voltage Modulation in Sol-Gel Indium-Gallium-Zinc Oxide (IGZO) Thin-Film Transistors

Wonsik Kim (Ajou Univ., Korea), Won-June Lee, Taehyun Kwak (GIST, Korea), Seokhyeon Baek (Ajou Univ., Korea), Seung-Hoon Lee (KRICT, Korea), and Sungjun Park (Ajou Univ., Korea)